

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s):	Donald W. Berrian	Confirmation No.:	6893
Serial No.:	10/032,664	Group No.:	2881
Filed:	October 19, 2001	Examiner:	David Vanore
For:	System and Method for Rapidly Controlling the Output of Ion Source for Ion Implantation		

Mail Stop Issue Fee  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

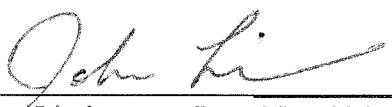
**COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE**

Sir:

The Examiner has cited reasons for allowance in this application in connection with the Notice of Allowance mailed March 16, 2007. It appears the Examiner's reasons for allowance do not recite the exact language of the claims. We wish to point out that the exact language of these claims is the best recitation supporting the reasons for allowance.

Further, Applicant wishes to point out that there are additional reasons for allowance, including features of independent and dependent claims not specifically referenced in the Notice of Allowance.

Respectfully submitted,

By:   
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